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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuhiro NAKAGAWA et al.

Group Art Unit: 1731

Application No.: 09/786,470

Examiner: C. Lopez

Filed: March 5, 2001

Docket No.: 108776

For: METHOD OF MANUFACTURING SILICA GLASS MEMBER AND SILICA GLASS
MEMBER OBTAINED BY THE METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 16, 2003 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.